

Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)	Docket Number (Optional) 3439.4US (97-936.3)	Application Number Not Yet Assigned 10/000,497
	Applicant Jigish D. Trivedi et al.	
	Filing Date October 24, 2001	Group Art Unit Unknown

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<u>Vu</u>	4,975,756	12/1990	Haken et al.	257	371	-
<u>Vu</u>	5,124,280	06/1992	Wei et al.	438	618	-
<u>Vu</u>	5,173,450	12/1992	Wei	438	620	-
<u>Vu</u>	5,341,016	08/1994	Prall et al.	257	412	-
<u>Vu</u>	5,391,520	02/1995	Chen et al.	438	620	-
<u>Vu</u>	5,451,545	09/1995	Ramaswami et al.	438	649	-
<u>Vu</u>	5,597,744	01/1997	Kamiyama et al.	438	285	-
<u>Vu</u>	5,654,575	08/1997	Jeng	257	384	-
<u>Vu</u>	5,766,997	06/1998	Takeuchi	438	257	-
<u>Vu</u>	5,981,380	11/1999	Trivedi et al.	438	639	-

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

<u>Vu</u>		T. Tang, et al., <i>Titanium Nitride Local Interconnect Technology for VLSI</i> , IEEE Trans. Electron Devices, Vol. ED-34, 3 (1987) p. 682.

EXAMINER HUNG K. JU	DATE CONSIDERED 10/29/02
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.